

Semiconductor devices — Micro-electromechanical devices —

Part 2: Tensile testing method of thin film materials

The European Standard EN 62047-2:2006 has the status of a
British Standard

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National foreword

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The UK participation in its preparation was entrusted to Technical Committee EPL/47, Semiconductors.

A list of organizations represented on EPL/47 can be obtained on request to its secretary.

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